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SUPPLIER	MODEL	DESCRIPTION
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200mm

SUPPLIER	MODEL	DESCRIPTION
APPLIED MATERIALS / AMAT	SEM VISION CX	AUTO DEFECT REVIEW SEM/EDX
HITACHI HTA	M712E	SHALLOW TRENCH ETCHER
KLA TENCOR CORPORATION	6200	SURFSCAN BARE
KLA TENCOR CORPORATION	RS55	OMNIMAP
KLA TENCOR CORPORATION	AIT-XP PLUS	PATTERNED WAFER INSPECTION, DARKFIELD
KLA TENCOR CORPORATION	QUANTOX 64100	GATE OXIDE SURFACE CHARGE
NIKON PRECISION INC	AM-601D	RETICLE INSPECTION
NIKON PRECISION INC	S204	248nm (0.68NA) SCANNER
LRC / NOVELLUS	SABRE-XT	CU ELECTROPLATER AUTO
RUDOLPH TECHNOLOGIES	METAPULSE 200	ADHESION THICKNESS
AKRION / SCP	9415	BACK END (CU)
AKRION / SCP	9415	TW #2 LITHO/TF-CU REGEN
AMAT / SEMITOOL	WST 308	SST C4
AMAT / SEMITOOL	WST 308	SST PI REAR EXHAUST
VARIAN	KESTREL 750	MEV IMPLANTER

300mm

SUPPLIER	MODEL	DESCRIPTION
APPLIED MATERIALS / AMAT	QUANTUM X+	SINGLE WAFER HIGH CURRENT IMPLANTER
ASM AMERICA INC	A412	DUAL REACTOR VDF CURE, CU, PI
AXCELIS TECHNOLOGIES INC	PS3	DUV CURE, DUAL CHAMBER
EBARA TECHNOLOGIES INC	UFP-300A	AUTO PLATER
EVATEC / OERLIKON	STARLINE 300	BACKSIDE METAL TOOL, C4
FEI	1265	DUAL BEAM FIB
FEI	EXPIDA 1255S	MANUAL LOAD, NO STEM, NGSEM COL
HITACHI	M712XT	ETCHER
HITACHI HTA	S9380	CD SEM
KLA TENCOR CORPORATION	AIT UV++	DARKFIELD PATTERN INSPECTION
KLA TENCOR CORPORATION	AIT-XP PLUS	PATTERNED WAFER INSPECTION, DARK FIELD
KLA TENCOR CORPORATION	SCD-XT	SCATTEROMETRY METROLOGY TOOL, NC
KLA TENCOR CORPORATION	SL3UV-URSA	RETICLE INSPECTION
LINTEC OF AMERICA INC	RAD3010F12	DETAPE FOR BACKSIDE GRIND, DP
NANOMETRICS INC	NANOSPEC 8300X	THIN FILMS MEASURING SYSTEM
NIKON PRECISION INC	9M(SF100)	EXPOSURE, PDPI, CU
NIKON PRECISION INC	S204	248NM (0.68NA) SCANNER
PANASONIC	YV-CSS011	LASER SCRIBE WITH DUAL BEAM
TEL	ACT12	STAND ALONE TRACK
TOKYO ELECTRON LTD / TEL	LITHIUS	SINGLE BLOCK
TOKYO ELECTRON LTD / TEL	TELIUS SCCM	ETCHER (2 SCCM CHAMBERS)
ULTRATECH INCORPORATED	SATURN SPEC 300	GHI EXPOSE TOOL, C4